

**PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80755

Kesahiro KOIKE

Appln. No.: 10/809,523

Group Art Unit: 1792

Confirmation No.: 7526

Examiner: Lan Vinh

Filed: March 26, 2004

For: METHOD OF PRODUCING A GLASS SUBSTRATE FOR A MASK BLANK AND
METHOD OF PRODUCING A MASK BLANK

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month(s), extending the time for responding to the Office Action of December 18, 2008 to April 18, 2008.

The statutory fee of \$120.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

/Alan J. Kasper/

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Date: April 16, 2008